#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2 FW

Applicant:

Zhiping Yin et al.

Title:

TRANSPARENT AMORPHOUS CARBON STRUCTURE IN SEMICONDUCTOR DEVICES

Docket No.:

303.864US1

Filed:

September 12, 2003

Examiner:

Unknown

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

MAY 2 8 2004 B

Serial No.: 10/661379

Due Date: N/A

Group Art Unit: 2661

We are transmitting herewith the following attached items (as indicated with an "X"):

- $\underline{X}$  A return postcard.
- X A Communication Concerning Related Applications (1 pg.).
- X A Supplemental Information Disclosure Statement (2 pgs.), Form 1449 (2 pgs.), and copies of 1 cited documents.

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

Atty: Viet V. Tong

Reg. No. 45,416

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this **Z471** day of May, 2004.

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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)

AY 2 8 2004

/N 10/661379 PATENT

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TRANSPARENT AMORPHOUS CARBON STRUCTURE IN

SEMICONDUCTOR DEVICES

## COMMUNICATION CONCERNING RELATED APPLICATIONS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

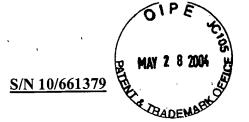
Applicants would like to bring to the Examiner's attention the following related applications in the above-identified patent application:

Serial/Patent No. 10/661100	Filing Date September 12, 2003	Attorney Docket 303.869US1	Title MASKING STRUCTURE HAVING MULTIPLE LAYERS INCLUDING AN AMORPHOUS CARBON LAYER				
10/789736	February 27, 2004	303.885US1	TRANSPARENT AMORPHOUS CARBON STRUCTURE IN SEMICONDUCTOR DEVICES				
		Respectfully su	bmitted,				
		ZHIPING YIN	ET AL.				
		By Applicants'	Representatives,				
SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. Box 2938 Minneapolis, MN 55402 (612) 373-6969							
Date5/2	4/04	By Viet V.	Tull-				

<u>CERTIFICATE UNDER 37 CFR 1.8:</u> The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this **297H** day of May, 2004.

JAMES KANYUS IK

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Zhiping Yin et al.

Examiner:

Unknown

Serial No.:

10/661379

Group Art Unit:

2661

Filed:

September 12, 2003

Docket:

303.864US1

Title:

TRANSPARENT AMORPHOUS CARBON STRUCTURE IN

SEMICONDUCTOR DEVICES

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 et. seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the Supplemental Information Disclosure Statement. However, if an Office Action on the merits has been mailed, the Commissioner is hereby authorized to charge the required fees to Deposit Account No. 19-0743 in order to have this Supplemental Information Disclosure Statement considered.

The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

The present application is either a U.S. national patent application filed after June 30, 2003 or an international application that entered the national stage under 35 U.S.C. § 371 after June 30, 2003. Thus, Applicant believes that the U.S. Patent & Trademark Office has waived the requirement under 37 C.F.R. 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication. The waiver is provided in a pre-OG notice from the U.S. Patent & Trademark Office entitled "Information Disclosure Statements May Be Filed

Page 2

### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Serial No :10/661379

Filing Date: September 12, 2003

Title: TRANSPARENT AMORPHOUS CARBON STRUCTURE IN SEMICONDUCTOR DEVICES

Dkt: 303.864US1

Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003" and dated July 11, 2003. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

Respectfully submitted,

ZHIPING YIN ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

P.O. Box 2938

Minneapolis, MN 55402

(612) 373-6969

Date

Viet V. Tong Reg. No. 45,416

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this **24TH**day of May, 2004.

PTO/SB/08A(10-01)
Approved for use through 10/31/2002. OMB 651-0031
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#### Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 2



<b>Application Number</b>	10/661379		
Filing Date	September 12, 2003		
First Named Inventor	Yin, Zhiping		
Group Art Unit	2661		
Examiner Name	Unknown		

Attorney Docket No: 303.864US1

	LIO DATENT DOCUMENTO							
	US PATENT DOCUMENTS							
Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate		
	US- 2001/0011730	08/09/2001	Saeki	257	79	02/08/2001		
	US- 2001/0017153	08/30/2001	Kubota, et al.	136	256	12/21/2000		
	US- 2002/0100696	08/01/2002	Sano, et al.	205	333	01/17/2002		
	US-4,849,642	07/18/1989	Katsumi,	250	492.2	12/10/1987		
	US-4,971,853	11/20/1990	Chaiken, et al.	428	172	05/04/1988		
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	US-6,107,734	08/22/2000	Taneka, et al.	313	506	09/28/1998		
	US-6,128,868	10/10/2000	Ohtsuka, et al.	52	173.3	09/03/1997		
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	US-6,140,652	10/31/2000	Schlepr et al.	250	440.11	09/09/1998		
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	US-6,300,631	10/09/2001	Shofner	250	311	10/07/1999		
	US-6,346,184	02/12/2002	Sano, et al.	205	199	05/08/1998		
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	US-6,613,603	09/02/2003	Sano	438	72	07/21/1998		

**EXAMINER** 

**DATE CONSIDERED** 

PTO/S8/08A(10-01)
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for the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Substitute for form 1449A/PTO Complete if Known INFORMATION DISCLOSURE 10/661379 **Application Number** STATEMENT BY APPLICANT September 12, 2003 (Use as many sheets as necessary) Filing Date Yin, Zhiping **First Named Inventor Group Art Unit** 2661 BADEMA MAY 2 8 2004 Unknown **Examiner Name** Attorney Docket No: 303.864US1 Sheet 2 of 2

	OTHER	R DOCUMENTS NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the it (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
		PELTON, MATTHEW, et al., "The optical absorption edge of diamond-like carbon: A quantum well model", <u>Journal of Applied Physics</u> , 83(2), (January 15, 1998),1029-35	